

## Electronic Patent Application Fee Transmittal

Application Number:	09824936			
Filing Date:	03-Apr-2001			
Title of Invention:		Plasma reactor for the treatment of large size substrates		
First Named Inventor/Applicant Name:	Jacques Schmitt			
Filer:	Peter C. Michalos/Chih-Sheng Lin			
Attorney Docket Number:	H37-091 DIV			

Filed as Large Entity

### Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Filing a brief in support of an appeal	1402	1	500	500
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Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>500</b>